

For: PROCESS FOR PRODUCING AN ELECTRODE

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Attention: DO/EO/US

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Respectfully submitted,

June 8, 2006  
Date

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

LAIN, Michael, Jonathan et al

Serial No. 10/568,067

U.S. National Stage Application of  
 International Appln. No. PCT/GB2004/003443

Attention: DO/EO/US

International Filing Date: 9 August 2004

For: **PROCESS FOR PRODUCING AN ELECTRODE**

**LIST OF DOCUMENTS SUBMITTED BY APPLICANT**  
**WITH INFORMATION DISCLOSURE STATEMENT**  
 (Substitute Form PTO-1449)

<b>U.S. Patent and Published Application Documents</b> (Number, Issue/Publication Date, and Patentee)					
Examiner Initial	Document Number	Document Date	Patentee	Class/Subclass	
	5,567,474	10/22/1996	DOVER	427	213.3
	5,776,369	07/07/1998	DOVER	252	309
	5,976,403	11/02/1999	DOVER	252	182.3
	2002/0017255 A1	02/14/2002	OGAWA	123	90.15
	2002/0050054	05/02/2002	NOH	29	623.3
	2002/0119373	08/29/2002	GAO	429	218.1
	2002/0170168	11/21/2002	GONZALEZ	29	623.5
	2002/0170169	11/21/2002	GONZALEZ	29	623.5

<b>Foreign Patent Documents</b> (Number, Publication Date, and Country or Patent Office)					
Examiner Initial	Document Number	Document Date	Country or Patent Office	Translation yes no	
	94/19100	09/01/1994	WIPO		
	2290537	01/03/1996	GB		
	0875951.A1	11/04/1998	EP		
	2319024	05/13/1998	GB		
	99/43034	08/26/1999	WIPO		
	01/65616	09/07/2001	WIPO		
	02/21632	03/14/2002	WIPO		

Inventor: LAIN ET AL

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<b>Other Documents</b> (Including Author, Title, Date and Place of Publication, Pertinent Pages, Etc.)	
	EPO, Patent Abstracts of Japan, English language abstract of JP 01059779.

Date Considered:

Examiner:

Examiner:

Initial if reference considered. Draw line through citation if not in conformance and not considered.  
 Include copy of this form with next communication to applicant.